

Notice of Allowability	Application No.	Applicant(s)
	09/774,921	SHIRAISHI, HIDEAKI
	Examiner	Art Unit
	Dung Nguyen	2871

-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address--

All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. **THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS.** This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.

1. This communication is responsive to 07/30/2004.

2. The allowed claim(s) is/are 1-4.

3. The drawings filed on 31 January 2001 are accepted by the Examiner.

4. Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).

a) All b) Some* c) None of the:

1. Certified copies of the priority documents have been received.

2. Certified copies of the priority documents have been received in Application No. _____.

3. Copies of the certified copies of the priority documents have been received in this national stage application from the International Bureau (PCT Rule 17.2(a)).

* Certified copies not received: _____.

Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application.

THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.

5. A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient.

6. CORRECTED DRAWINGS (as "replacement sheets") must be submitted.

(a) including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached
1) hereto or 2) to Paper No./Mail Date _____.

(b) including changes required by the attached Examiner's Amendment / Comment or in the Office action of
Paper No./Mail Date _____.

Identifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet. Replacement sheet(s) should be labeled as such in the header according to 37 CFR 1.121(d).

7. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL.

Attachment(s)

- 1. Notice of References Cited (PTO-892)
- 2. Notice of Draftperson's Patent Drawing Review (PTO-948)
- 3. Information Disclosure Statements (PTO-1449 or PTO/SB/08),
Paper No./Mail Date _____
- 4. Examiner's Comment Regarding Requirement for Deposit
of Biological Material
- 5. Notice of Informal Patent Application (PTO-152)
- 6. Interview Summary (PTO-413),
Paper No./Mail Date _____
- 7. Examiner's Amendment/Comment
- 8. Examiner's Statement of Reasons for Allowance
- 9. Other _____.

DETAILED ACTION

Applicant's amendment dated 07/30/2004 has been received and entered. By the amendment, claims 1-4 are remain pending in the application.

Examiner's Amendment

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

In view of the Examiner's restriction requirement and subsequent election dated 04/30/2003 without traverse, claims 5-11 have been withdrawn from consideration, and they are now canceled by this Examiner's amendment.

Reasons for Allowance

2. Claims 1-4 are allowed.
3. The following is an examiner's statement of reasons for allowance:

None of the prior art of record suggests or discloses alone or in combination that a method of fabricating a liquid crystal display substrate comprising the step of forming at least two scribe cracks only on a second face of a first sheet and only on the first face of a second sheet, said at least two scribe cracks intersecting each other on the second face of the first sheet and intersecting each other on the first face of the second sheet, adhering the two sheets of substrates to each other so that said faces on which said

scribe cracks are formed oppose each other via a seal layer disposed so as to enclose an area, on which a liquid crystal layer is scheduled to be formed, and via a dummy seal layer disposed to prevent bias of stress when cutting the substrate and cutting the adhered substrate as set forth in claim 1.

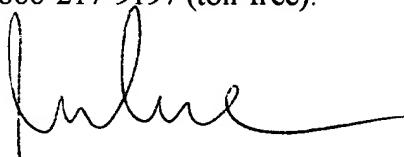
The most relevant reference, the combination of Nakahara et al (US 6,239,855) and Shishido et al (JP 9-311323), fail to disclose or suggest a step of forming at least two scribe cracks only on a second face of a first sheet and only on the first face of a second sheet and then adhering the two sheets of substrates to each other so that said faces on which said scribe cracks are formed oppose each other via a seal layer disposed so as to enclose an area, on which a liquid crystal layer is scheduled to be formed. The combination of Nakahara and Shishido reference disclose a method of providing a scribe line on both inner and outer faces of a pair of sheets before cutting.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Dung Nguyen whose telephone number is 571-272-2297. The examiner can normally be reached on Monday-Thursday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Robert H. Kim can be reached on 571-272-2293. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).



Dung Nguyen
Primary Examiner
Art Unit 2871

DN
11/01/2004